

Form PTO- 1449	Att. Docket Number :	Serial number : 09/446174 <i>H-2</i>
U.S. Department of Commerce Patent and Trademark Office		
Information Disclosure Statement by Applicant		
 Applicant : RUBBIA		
Filing date : 6/1997		Group : 3641

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	PATENTEE/APPLICANT	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>et</i>	5,160,696	11/03/92	Bowman	376	189	
<i>et</i>	3,998,691	12/21/76	Shikata, et al.	176	16	
<i>et</i>	4,017,583	04/12/77	Motojima, et al.	423	2	
<i>et</i>	4,721,596	01/26/88	Marriott, et al.	376	189	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	PUBLIC DATE	COUNTRY/AGENCY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
<i>et</i>	WO90/06583	06/14/90	WIPO	376	—	✓	
<i>et</i>	WO95/12203	05/04/95	WIPO	376	—	✓	
<i>et</i>	6,629/66	12/07/67	AU	376	—	✓	
<i>et</i>	WO95/10114	04/13/95	WIPO	376	—	✓	

Other Documents (Including Author, Title, Date, Pertinent Pages, Place of Publication, Etc.)

<i>et</i>	Yoshida HYOGO, « Method and Apparatus of Neutron Radiography », THE JAPAN STEEL WORKS LTD., NIPPON SEIKOSHO KK, Japanese Patent no. 60192244, September 30, 1985, Patent Abstracts of Japan, Vol. 10, no. 48, Page 431, February 25, 1986
<i>et</i>	Sano AKIRA, « Non-Destructive Analysis Apparatus For Fissile Material », TOSHIBA CORP., NIPPON ATOM IND. GROUP CO. LTD, Japanese Patent no. 02157696, June 18, 1990, Patent Abstracts of Japan, Vol. 14, no. 405, Page 1100, August 31, 1990
<i>et</i>	B. M. VTYURIN, et al., « Differential Diagnose Thyroid Gland Cancer Iodine Concentrate Determine New Tissue Neutron Activate Analyse Compare Normal Level », DATABASE WPI, A MEDECINE RADIOLOG, Soviet Union patent number 76 429566, June 30, 1978

Examiner <i>et</i>	Date Considered 9/02
EXAMINER : Initial if citation is considered, whether or not citation is in conformance with MPEP 609; Draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Form PTO- 1449 U.S. Department of Commerce Patent and Trademark Office Information Disclosure Statement by Applicant	Att. Docket Number : FEB 10 2000 PATENT & TRADEMARK OFFICE SEC 35	Serial number : 09/446144
Applicant : RUBBIA		
Filing date : 6/19/97		Group : 3641

U.S. PATENT DOCUMENTS

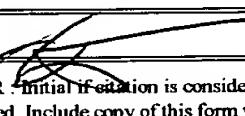
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	PATENTEE/APPLICANT	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	PUBLIC DATE	COUNTRY/AGENCY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

Other Documents (Including Author, Title, Date, Pertinent Pages, Place of Publication, Etc.)

	Matsushita YOSHIAKI, « Manufacture of Semiconductor Substrate », TOSHIBA CORP., Japanese patent publication no. 62202528, September 7, 1987, Patent Abstracts of Japan, vol 1. 12, no. 060, February 23, 1988
	K.M. ITOH, et al., "Neutron Transmutation Doping of Isotopically Engineered Ge", APPLIED PHYSICS LETTERS, April 18, 1994, USA, Vol. 64, No. 16, Pages 2121-2123
	DORYOKURO KAKUNENRYO KAIHATSU, "Decaying Method for Radioactive Waste – by Using Neutrons Generated Through Muon-Catalysed Fusion Reaction to Decay First Strontium or Caesium Blanket, Decaying Intermediate Trans-Uranium Blanket, Decaying Second Zirconium, Technetium, Iodine or Caesium Blanket, etc.", DATABASE WPI, Japan Patentno. 07 239397, September 12, 1995

Examiner 	Date Considered 4/02
EXAMINER Initial if citation is considered, whether or not citation is in conformance with MPEP 609; Draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	